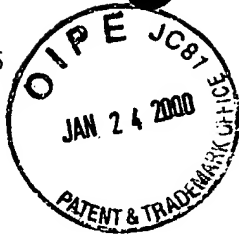


CS-99-065



January 3, 2000

To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

Subject:

Serial No. 09/442,499 11/18/99

Paul Kwok Keung Ho, Xue Chun Dai

PLASMA ETCH METHOD FOR FORMING
PLASMA ETCHED SILICON LAYER

Grp. Art Unit: 1765

ASSOCIATE POWER OF ATTORNEY

I hereby appoint Alek Szecsy, registration number
37,949, as my associate attorney in this case. His telephone
number is (914) 471-0790.

Please continue to direct all correspondence in this case
to the undersigned attorney.

Respectfully submitted,

Stephen B. Ackerman,

Principal attorney of record

RECEIVED
JAN 28 2000
TC 1700 MAIL ROOM